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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Masateru NAKAMURA

Group Art Unit: 1754

Application No.: 10/566,607

Docket No.: 126868

Filed: January 31, 2006

For: METHOD OF PRODUCTION OF SILICON CARBIDE SINGLE CRYSTAL

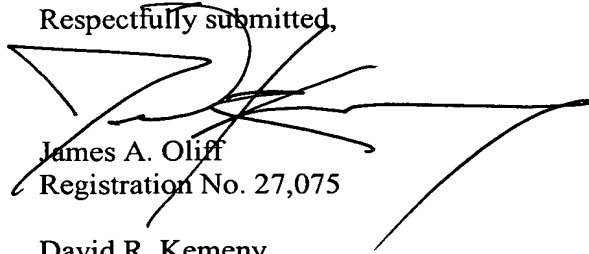
REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
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Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

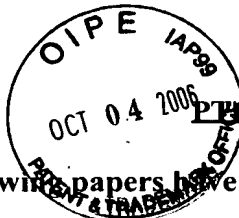
David R. Kemeny
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JAO:DRK/emt

Date: October 4, 2006

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PATENT RECEIPT FOR FILING OF PAPERS

The following papers have been filed:

PCT t; ck 175900 (\$900); PRELIM; 31 pp. spec/11 claims/abst; 9 pp. form draw (figs 1-10);
PCT Request; dec; assign t; ck 175892 (\$40); assign; ids; 1449; 3 ref; 2 abst; 2 trans; ISR;

Name of Applicant: Masateru NAKAMURA

Serial No.: New U.S. Patent Application

Atty. File No.: 126868

Title (New Cases): METHOD OF PRODUCTION OF SILICON CARBIDE SINGLE CRYSTAL

Sender's Initials: JAO/per

104/14

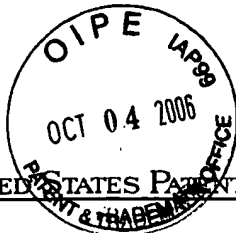
NEW APPLICATION

PATENT OFFICE DATE STAMP



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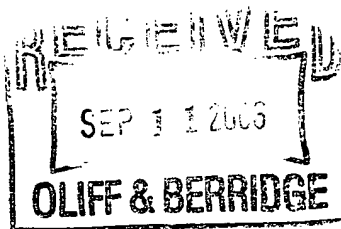


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/566,607	07/21/2006 1-31-2006	1754	1030	126868	9	11	2

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CONFIRMATION NO. 7140

FILING RECEIPT



OC000000020303813

Date Mailed: 09/06/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

Toyota-shi
 TOYOTA JIDOSHA KABUSHIKI KAISHA, ATCHI, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/17652 11/19/2004

Foreign Applications

JAPAN 2003-394083 11/25/2003

If Required, Foreign Filing License Granted: 09/05/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/566,607**

Projected Publication Date: 12/14/2006

Non-Publication Request: No

Early Publication Request: No

Title

Method of production of silicon carbide single crystal

Preliminary Class

423

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